

Lecture 4

MOSFET (III) - I-V Characteristics

EE101B

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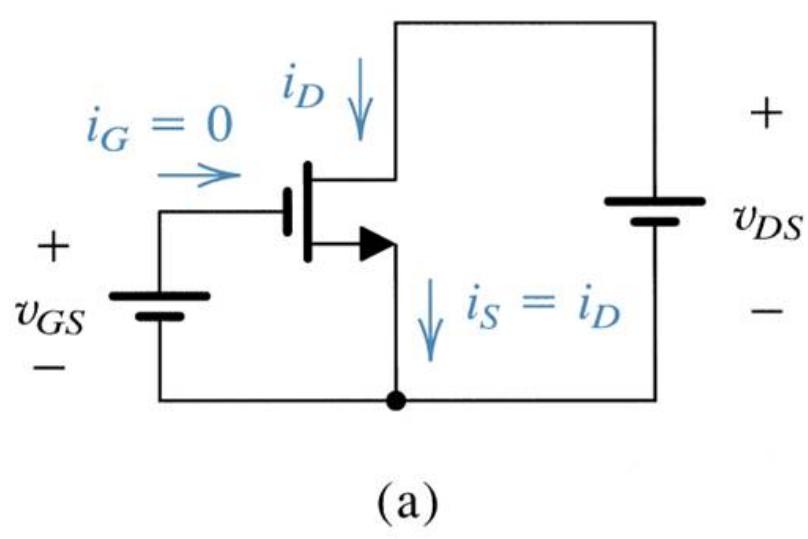
- i_D-v_{DS} characteristics
- Output resistance in saturation
- P-channel MOSFET (PMOS)
- The body effect

¹Primary reference: 4.2 (MOSFETs), A.S. Sedra and K.C. Smith, "Microelectronic Circuits", Fifth Edition. Oxford University Press, 2004.

i_D - v_{DS} characteristics

We now consider the complete "static" current-voltage (i-v) characteristics.

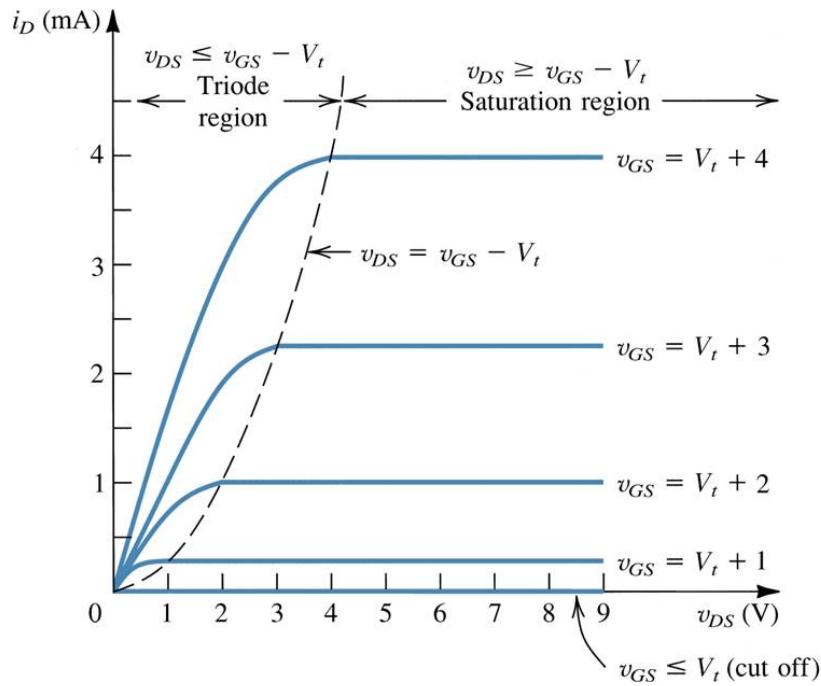
- "Static" characteristics mean characteristics valid at dc and low frequencies.
- Characteristics valid at mid- and high-frequencies will be considered later in EE101B.
- Figure: An n-channel enhancement-type MOSFET with v_{GS} and v_{DS} applied. Normal directions of current flow are indicated.



(a)

- This conceptual/test circuit is useful for envisioning i-v characteristics.
- The i-v characteristics comprise a family of curves.
- Each curve should appear as we saw last lecture, with each curve corresponding to a different v_{GS} .

- Figure: The i_D - v_{DS} characteristics for a device with $V_t = 1$ V and $k_n(W/L) = 0.5$ mA/V².



- Three distinct regions of operation can be clearly seen:

Cutoff region:

$$v_{GS} \leq V_t \quad \text{no channel induced} \quad (1)$$

$$i_D = 0 \quad (2)$$

Triode region:

$$v_{GS} > V_t \quad \text{channel induced} \quad (3)$$

$$v_{DS} \leq v_{GS} - V_t \quad \text{continuous channel} \quad (4)$$

$$i_D = k'_n \left(\frac{W}{L} \right) \left[(v_{GS} - V_t)v_{DS} - \frac{1}{2}v_{DS}^2 \right] \quad (5)$$

Saturation region:

$$v_{GS} > V_t \quad \text{channel induced} \quad (6)$$

$$v_{DS} \geq v_{GS} - V_t \quad \text{pinched-off channel} \quad (7)$$

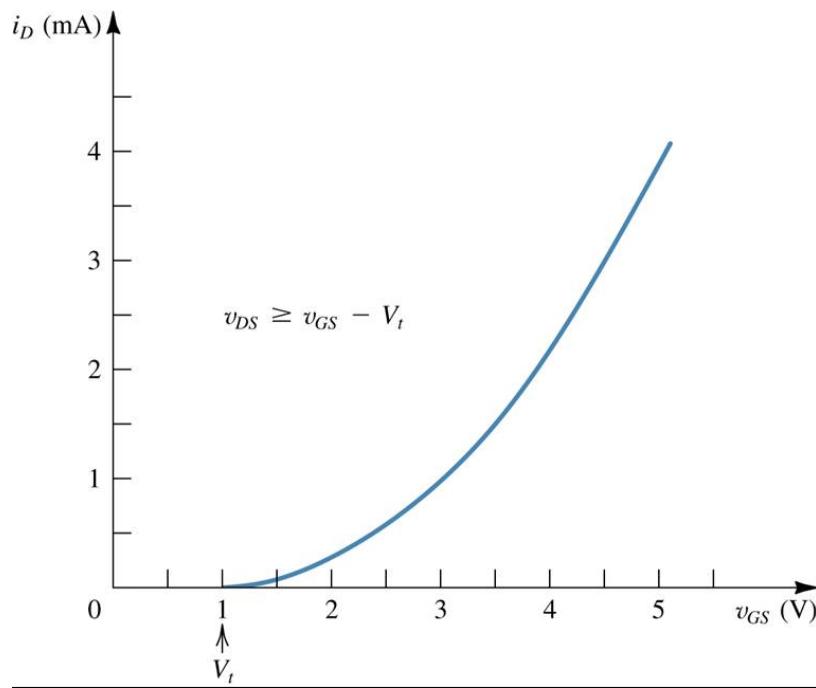
$$i_D = \frac{1}{2}k'_n \left(\frac{W}{L} \right) (v_{GS} - V_t)^2 \quad (8)$$

- Boundary between triode and saturation regions:

$$v_{DS} = v_{GS} - V_t.$$

- The BIG PICTURE here is how the three terminal voltages (G, S, D) fully determine the mode in which the MOSFET operates.
- In saturation, current is independent of v_{DS} and increases as the square of v_{GS} .
- This is termed "square law" behavior.
- In saturation, a MOSFET is an ideal current source: current does not depend on v_{DS} . (Note that we will revisit this approximation shortly).

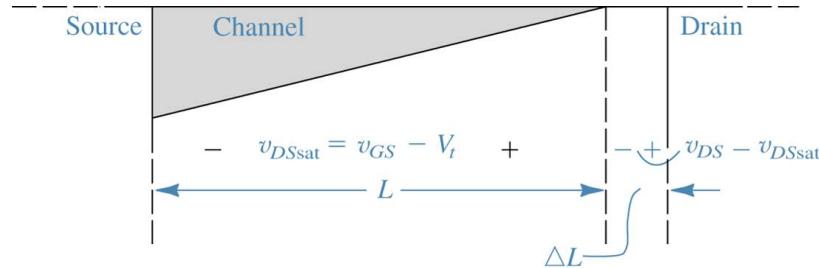
- Figure: The i_D - v_{GS} characteristic for an enhancement-type NMOS transistor in saturation ($V_t = 1$ V and $k_n(W/L) = 0.5$ mA/V²).



Output resistance in saturation

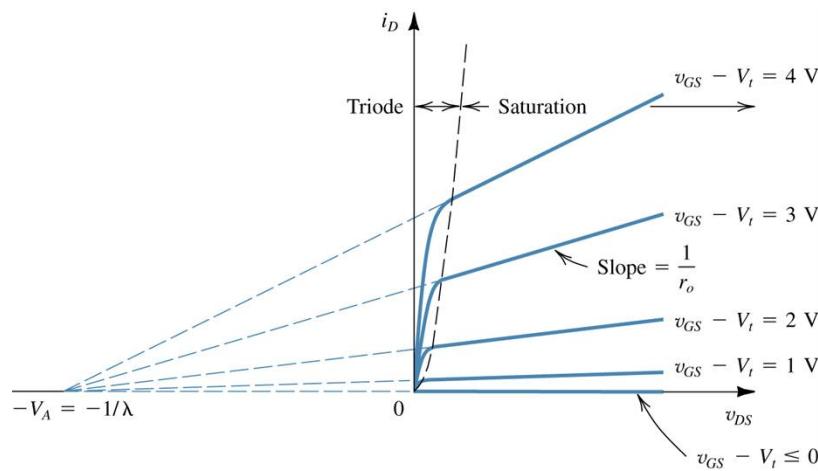
The complete independence of saturation current on v_{DS} is only an approximation, and we must now revisit this approximation.

- The approximation relies on the channel not changing shape once it is pinched off.
- In reality, as v_{DS} increases beyond v_{DSsat} the pinch off point moves slightly toward the source.
- Figure: Increasing v_{DS} beyond v_{DSsat} causes the channel pinch-off point to move slightly away from the drain, thus reducing the effective channel length (by ΔL).



- This phenomenon is termed *channel-length modulation*.
- Since i_D is inversely proportional to L , channel-length modulation implies that i_D will increase with v_{DS} beyond v_{DSsat} .
- This is illustrated in the figure below.

- Figure: Effect of v_{DS} on i_D in the saturation region. The MOSFET parameter V_A is typically in the range of 30 to 200 V.



- The linear dependence of i_D on v_{DS} in the saturation region is taken into account through a channel-length modulation term λ :

$$i_D = \frac{1}{2} k'_n \left(\frac{W}{L} \right) (v_{GS} - V_t)^2 (1 + \lambda v_{DS}) \quad (1)$$

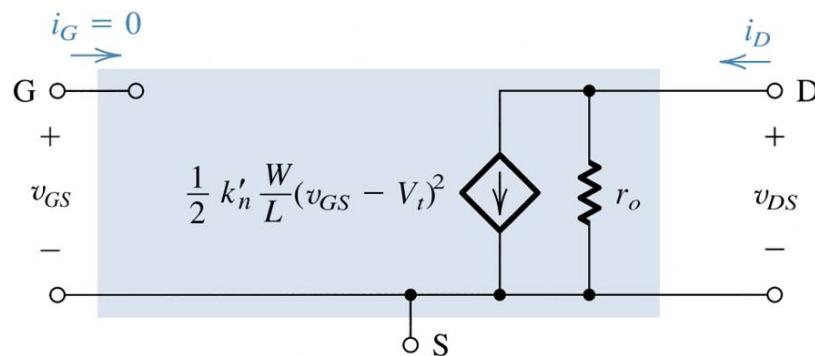
- Note that L is the original (longest) channel length in this equation.
- As shown in the figure above, extrapolations of the saturation current characteristics intersect at the Early voltage (V_A).
- V_A is the inverse of λ .
- λ is typically 0.005 to 0.03 V^{-1} .
- Channel-length modulation makes the output resistance finite (not infinite) in the saturation region:

$$r_o = \left[\frac{\partial i_D}{\partial v_{DS}} \right]_{v_{GS}=\text{constant}}^{-1} \quad (2)$$

$$r_o = \left[\lambda \frac{k'_n W}{2 L} (V_{GS} - V_t)^2 \right]^{-1} \quad (3)$$

$$r_o \approx \frac{1}{\lambda I_D} = \frac{V_A}{I_D} \quad (4)$$

- Note 1: The approximation is due to neglecting the $(1 + \lambda v_{DS})$ term when substituting in I_D .
- Note 2: I_D is dc current flowing through the MOSFET.
- The figure below is the large-signal equivalent circuit model of a MOSFET.
- Figure: Large-signal equivalent circuit model of the n-channel MOSFET in saturation, incorporating the output resistance r_o . The output resistance models the linear dependence of i_D on v_{DS} and is given by $r_o \approx V_A/I_D$.



P-channel MOSFET (PMOS)

PMOS i-v characteristics and equations are nearly identical to those of the NMOS transistor we have been considering.

- Recall that $V_t < 0$ since holes must be attracted to induce a channel.
- Thus, to induce a channel and operate in triode or saturation mode:

$$v_{GS} \leq V_t \quad (5)$$

- For PMOS, v_D is more negative than v_S – thus $v_{DS} < 0$ (or equivalently $v_{SD} > 0$).
- Thus, to operate in the triode region:
 - $v_{DS} \geq v_{GS} - V_t$ (continuous channel)
 - Current equation is the same as for NMOS, but with k'_p instead of k'_n .
 - Note: $\mu_p \approx 0.4\mu_n$
- To operate in the saturation region:
 - $v_{DS} \leq v_{GS} - V_t$ (pinched-off channel)
 - Current equation is the same as for NMOS, but with k'_p instead of k'_n .

The Body Effect

So far we have ignored the substrate (body) terminal, but now we must consider this terminal in greater detail.

- Consider an NMOS transistor.
- We typically tie the backgate terminal to the source.
- In this case we can ignore the backgate terminal.
- It is not always possible to connect the backgate terminal to each transistor's source.
- In integrated circuits, the backgate is usually tied to the most negative power supply in the circuit (most positive for PMOS).
- If the backgate terminal voltage is less than the source voltage (for NMOS) a reverse-bias p-n junction results.
- This, in turn, will have an effect on device operation:
 - The depletion region between substrate and channel will widen.
 - This reduces the number of channel carriers ("channel depth").
 - To restore the number of carriers, v_{GS} would have to be increased
- The most convenient way to represent the influence of a non-zero V_{SB} is to alter the threshold voltage V_t .

- Specifically, increasing the reverse substrate bias voltage V_{SB} results in an increase in V_t :

$$V_t = V_{to} + \gamma \left[\sqrt{2\phi_f + V_{SB}} - \sqrt{2\phi_f} \right] \quad (6)$$

where:

- V_{to} is the threshold voltage for $V_{SB} = 0$.
- ϕ_f is a physical parameter with $2\phi_f$ typically 0.6 V.
- γ is a fabrication-process parameter given by:

$$\gamma = \frac{\sqrt{2qN_A\epsilon_s}}{C_{ox}} \quad (7)$$

- N_A is the doping concentration of the p-type substrate.
- ϵ_s is the permittivity of silicon.

- The BIG PICTURE here is that an incremental change in V_{SB} gives rise to an incremental change in V_t , which in turn results in an incremental change in i_D .
- In effect, the substrate (body terminal) acts as another gate in that it exerts control over channel current (i_d).
- This phenomenon is termed the *body effect*.
- The γ parameter is called the *body-effect parameter*.